



Attorney's Docket No.: 4711 USA/P01/W-C/W-C/JB1

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: )  
Steven Verhaverbeke et al. ) Examiner: Markoff, Alexander  
U.S. Serial No: 09/891,849 ) Art Unit: 1746  
Filed: June 25, 2001 )  
For: METHOD AND APPARATUS FOR)  
WAFER CLEANING )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE**

Dear Sir:

This is in response to the Final Office Action mailed March 23, 2005 and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicant respectfully requests the Examiner to enter this Preliminary Amendment and consider the following remarks.

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP RCE  
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